	Application No.	Applicant(s)
Notice of Allowability	10/531,194	MIGEON ET AL.
	Examiner	Art Unit
	Nikita Wells	2881
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. This communication is responsive to <u>Application filed 13 April 2005</u> .		
2. The allowed claim(s) is/are <u>1-17</u> .		
3. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  a) All b) Some* c) None of the:  1. Certified copies of the priority documents have been received.		
2. Certified copies of the priority documents have been received in Application No.		
3.  Copies of the certified copies of the priority documents have been received in this national stage application from the		
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.  THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		
4. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.		
5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.		
(a) 🔲 including changes required by the Notice of Draftsperson's Patent Drawing Review ( PTO-948) attached		
1)  hereto or 2)  to Paper No./Mail Date		
(b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date		
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).		
6. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.		
Attachment(s)	5 <b></b>	
1. Notice of References Cited (PTO-892)	5. Notice of Informal F	
<ol> <li>Notice of Draftperson's Patent Drawing Review (PTO-948)</li> <li>MInformation Disclosure Statements (PTO/SB/08),</li> </ol>	6. ☐ Interview Summary Paper No./Mail Da 7. ☐ Examiner's Amend	te
Paper No./Mail Date <u>04/13/05</u>	<del></del>	
<ol> <li>Examiner's Comment Regarding Requirement for Deposit of Biological Material</li> </ol>		ent of Reasons for Allowance
	v. 🔲 Ouiei	
		Nikita Wells Primary Examiner Art Unit: 2881

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## **DETAILED ACTION**

## Allowable Subject Matter

1. Claims 1-17 are allowed.

2. The following is an examiner's statement of reasons for allowance:

With respect to the independent claim 1, prior art fails to disclose or make obvious, in combination with other recited features of the claim limitations, a method for modifying electronic properties of a sample surface to analytical ends, comprising in situ deposition of neutral cesium (Cs<sup>0</sup>), under ultra-high vacuum, said neutral cesium being enabled in the form of a collimated adjustable stream, said Cs<sup>0</sup> deposition being simultaneously accompanied by a primary bombardment of said surface, in the form of at least a beam comprising electrons and/or ions or neutral atoms or groups of atoms, or by an X-ray irradiation, intended to induce a secondary emission or sputtering of particles for analysis, out of the surface, said sputtering comprising secondary electrons and/or Cs<sub>x</sub><sup>n+</sup> and/or positive clusters and/or negative ions, the Cs<sup>0</sup> deposition being decoupled from the primary bombardment conditions, to provide a simultaneous optimization of deposited Cs<sup>0</sup> concentration and analytical characteristics, such as the depth resolution, characterized in that said optimized deposited Cs<sup>0</sup> concentration is chosen only by adjusting the ratio between the erosion rate and the Cs<sup>0</sup> deposition rate, for a given sample and given primary bombardment conditions.

The dependent claims 2-17 are allowable by virtue of their dependence upon the independent claim 1.

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## Conclusion

3. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Zacharias et al. (2,972,115) disclose a molecular beam apparatus utilizing a cesium beam but fail to disclose all the claim limitations as presented by the Applicant in claim 1.

- 4. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."
- 5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Nikita Wells whose telephone number is (571) 272-2484. The examiner can normally be reached on 8:30 AM 5:00 PM. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Drew Dunn can be reached on (571) 272-2312. The central fax phone number for the organization where this application or proceeding is assigned is (571) 273-8300.
- 6. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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Nikita Wells, Primary Examiner

Art Unit 2881 January 4, 2007